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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/666,334	09/22/2003	Ryuichi Kurosawa	117237	8378
25944 7:	590 01/11/2005		EXAM	INER
OLIFF & BEI	RRIDGE, PLC	SHAFER, RICKY D		
P.O. BOX 19928 ALEXANDRIA, VA 22320				
			ART UNIT	PAPER NUMBER
	,		2872	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Ac.			
	Application No.	Applicant(s)			
Office Action Commons	10/666,334	KUROSAWA			
Office Action Summary	Examiner ·	Art Unit			
	Ricky D. Shafer	2872			
The MAILING DATE of this communication appeariod for Reply	pears on the cover sheet with the	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPL THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.  after SIX (6) MONTHS from the mailing date of this communication.  If the period for reply specified above is less than thirty (30) days, a rep  If NO period for reply is specified above, the maximum statutory period  Failure to reply within the set or extended period for reply will, by statut Any reply received by the Office later than three months after the mailir earned patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may a reply be to ly within the statutory minimum of thirty (30) da will apply and will expire SIX (6) MONTHS from e, cause the application to become ABANDON	imely filed  sys will be considered timely.  In the mailing date of this communication.  ED (35 U.S.C. § 133).			
Status					
<ul> <li>1) Responsive to communication(s) filed on 22 S</li> <li>2a) This action is FINAL. 2b) This</li> <li>3) Since this application is in condition for allowed closed in accordance with the practice under</li> </ul>	s action is non-final. ance except for formal matters, p				
Disposition of Claims					
4) ☐ Claim(s) 1-14 is/are pending in the application 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) 1-14 are subject to restriction and/or Application Papers 9) ☐ The specification is objected to by the Examin	ewn from consideration.  election requirement.				
10)☐ The drawing(s) filed on is/are: a)☐ acc	10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.				
Applicant may not request that any objection to the					
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the E					
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureat * See the attached detailed Office action for a list	nts have been received. Its have been received in Applica ority documents have been receiv au (PCT Rule 17.2(a)).	tion No ved in this National Stage			
Attachment(s)	_				
1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summai Paper No(s)/Mail I				
<ul> <li>2) Notice of Dransperson's Patent Drawing Review (P10-946)</li> <li>3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08 Paper No(s)/Mail Date</li> </ul>		Patent Application (PTO-152)			

Art Unit: 2872

1. Restriction to one of the following inventions is required under 35 U.S.C. 121:

- I. Claims 1-10, drawn to a mirror device comprising a mirror substrate having at least one first and second mirror-side operating regions and a substrate having at least one first and second opposite-side operating sections, wherein the first and second mirror-side operating regions and the first and second opposite-side operating sections are formed so that an attractive force is generated and wherein at least one of the mirror substrate and the support substrate is formed so that a gap between the first mirror-side operating region and the first opposite-side operating sections is narrower than a gap between the second mirror-side operating region and the second opposite-side operating section, classified in class 359, subclass 295.
- Claims 11-14, drawn to a method for driving a mirror device comprising a mirror II. substrate having a mirror which is driven by a predetermined distance-dependent driving force and a support substrate with particular distance-dependent driving force details, classified in class 359, subclass 224.
- The inventions are distinct, each from the other because of the following reasons: 2.

Inventions II and I are related as process and apparatus for its practice. The inventions are distinct if it can be shown that either: (1) the process as claimed can be practiced by another materially different apparatus or by hand, or (2) the apparatus as claimed can be used to practice another and materially different process. (MPEP § 806.05(e)). In this case, the process as claimed can be practiced by another materially different apparatus such as an apparatus without a

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mirror substrate having at least one first and second mirror-side operating regions and/or a substrate having at least one first and second opposite-side operating sections.

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- 3. Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification and/or because of their recognized divergent subject matter, restriction for examination purposes as indicated is proper.
- 4. Applicant is advised that the reply to this requirement to be complete must include an election of the invention to be examined even though the requirement be traversed (37 CFR 1.143).
- 5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Ricky D. Shafer whose telephone number is (571) 272-2320. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

**RDS** 

January 10, 2005